

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re United States Patent Application of:

Customer No.: 25559

Applicant: Peter Van Buskirk, et al.

Docket No.: 2771-337 RCE 2

Application No.: 09/200,495

Examiner: S. Hu

Date Filed: November 25, 1998

Art Group: 2811

**Title: OXIDATIVE TOP
ELECTRODE DEPOSITION
PROCESS, AND
MICROELECTRONIC
DEVICE STRUCTURE**

Confirmation No.: 4898

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ATTN: Examiner Hu
Fax No. (703) 872-9306

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission to Commissioner for Patents, Mail Stop AF, PO Box 1450, Alexandria, VA 22313-1450, on March 23, 2004 to United States Patent and Trademark Office facsimile transmission number (703) 872-9306.

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Number of Pages (including cover)


Marianne Fuierer

March 23, 2004

Date _____

**RESPONSE TO JANUARY 23, 2004 OFFICE ACTION
IN U.S. PATENT APPLICATION NO. 09/200,495**

**Mail Stop AF
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450**

Sir:

In response to the Office Action dated January 23, 2004, in the above-identified patent application, please amend the application as follows: